



Express Mail No. EV622661191US

Attorney Docket No. 108298715US
Disclosure No. 03-0117.00/US

PTO/SB/08a/b (08-03)

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete If Known	
				Application Number	10/646,673-Conf. #1020
				Filing Date	August 21, 2003
				First Named Inventor	Kevin L. Beaman
				Art Unit	1762
				Examiner Name	T. H. Meeks
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.†	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
DT		US-09/651,037	Filed 08-30-2000	Mardian	
		US-10/365,085	Filed 02-11-2003	Carpenter et al.	
		US-10/665,099	Filed 09-17-2003	Basceri et al.	
		US-10/665,908	Filed 09-18-2003	Sarigiannis et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
		US-10/683,606	Filed 10-09-2003	Derderian	
		US-10/687,458	Filed 10-15-2003	Kubista et al.	
		US-10/733,523	Filed 12-10-2003	Beaman et al.	
		US-10/767,298	Filed 01-28-2004	Zheng et al.	
		US-10/814,573	Filed 03-31-2004	Gealy et al.	
		US-10/839,316	Filed 05-05-2004	Saragiannis et al.	
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		US-10/859,883	Filed 06-02-2004	Miller et al.	
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		US-11/018,142	Filed 12-20-2004	Rueger et al.	
		US-11/027,809	Filed 12-29-2004	Carpenter et al.	
DT		US-11/027,825	Filed 12-29-2004	Derderian et al.	

Examiner Signature		Date Considered	4/17/05
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/646,673-Conf. #1020
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	US-11/043,629	Filed 01-25-2005	Rueger et al.	
	US-2001/0010309-A1	08-02-2001	Van Bilsen	
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	US-2002/0110991-A1	08-15-2002	Li	
	US-2002/0127745-A1	09-12-2002	Lu et al.	
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	US-2002/0185067-A1	12-12-2002	Upham	
	US-2002/0195056-A1	12-26-2002	Sandhu et al.	
	US-2002/0195201-A1	12-26-2002	Beer	
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	US-2003/0000473-A1	01-02-2003	Chae et al.	

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				Examiner Name	T. H. Meeks
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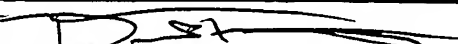
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	US-5,788,778	08-04-1998	Shang et al.	
	US-5,792,269	08-11-1998	Deacon et al.	
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	US-5,820,641	10-13-1998	Gu et al.	
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	US-5,833,888	11-10-1998	Arya et al.	
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	US-5,956,613	09-21-1999	Zhao et al.	
	US-5,968,587	10-19-1999	Frankel	
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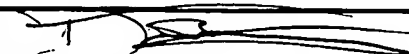
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